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Nanoporous silicon-based surface patterns fabricated by UV laser interference techniques for biological applications

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Abstract
The fabrication of selectively functionalized micropatterns based on nanostructured porous silicon (nanoPS) by phase mask ultraviolet laser interference is presented here. This single-step process constitutes a flexible method for the fabrication of surface patterns with tailored properties. These surface patterns consist of alternate regions of almost untransformed nanoPS and areas where nanoPS is transformed into Si nanoparticles (Si NPs) as a result of the laser irradiation process. The size of the transformed areas as well as the diameter of the Si NPs can be straightforwardly tailored by controlling the main fabrications parameters including the porosity of the nanoPS layers, the laser interference period areas, and laser fluence. The surface patterns have been found to be appropriate candidates for the development of selectively-functionalized surfaces for biological applications mainly due to the biocompatibility of the untransformed nanoPS regions.

Keywords: biomaterials, laser interference, micropattern

Introduction
Nanostructured porous silicon (nanoPS) can be regarded as a somewhat complex network of silicon nanocrystals embedded into a porous matrix [1]. This nanomaterial is generally fabricated by the electrochemical etching of silicon wafers in hydrofluoric acid (HF)-based solutions. When crystalline silicon is transformed into nanoPS during the anodization process, quantum confinement effects (QCEs) manifest as a consequence of the reduction in size of the Si crystals [2]. This process also leads to several other novel physico-chemical properties. In fact, the efficient photoluminescence and electroluminescence in the visible range at room temperature are commonly attributed to QCEs [3, 4]. In addition, the tunable optical and structural properties of nanoPS, together with its high surface reactivity which opens the possibility of transforming it into a biocompatible material, make nanoPS an appropriate nanostructured material for the development of a wide variety of devices in a broad range of fields including electronics, photonics, telecommunications, and biomedicine [5–7].

Surface micro- and nanopatterning are becoming important techniques to enhance the performance of ‘traditional’ materials. In the case of nanoPS, different patterns have been developed for such applications as photonic devices, diffraction gratings, high-sensitivity biosensors, etc [8–10]. In order to fabricate these patterns, various techniques such as dry soft
lithography [11], press stamp [12], ion bombardment [13], or microstructuring crystalline silicon before electrochemical etching [14] have been used. One of the most used and precise technique is the combination of focused high-energy proton beams and electrochemical etching [15]. In this particular case, the selective formation of nanoPS allows the development of a wide variety of photonic devices including waveguides and photonic crystals [16, 17]. In addition, due to the biocompatibility of Si and nanoPS, these patterns have been also used for the fabrication of tailored platforms for cell adhesion [18, 19]. However, none of these methods have the capability to offer flexibility in the pattern design in a time-efficient process, over large areas, and in a single-step process.

In this context, the present work reports on the fabrication of 1D- and 2D surface patterns based on nanoPS by phase mask ultraviolet laser interference. This is a single-step and flexible approach which allows producing an ample variety of patterns consisting in defined regions of almost untransformed nanoPS and areas where nanoPS has been transformed into Si nanoparticles (Si NPs). Furthermore, by controlling the main parameters in the fabrication process such as nanoPS porosity and laser fluence, the key features of the patterns, including the period and the diameter of the Si NPs, can be precisely tailored. In addition, the production of selectively functionalized surfaces from these patterns is presented.

Experimental

Nanostructured porous silicon fabrication

NanoPS layers were fabricated by electrochemical etching low resistivity p-type silicon wafers ($\rho = 0.01 - 0.05 \, \Omega \cdot \text{cm}$; orientation $<100>$) in HF (48 wt.%):ethanol (98 wt.%) (1:2) solutions. The current density was adjusted between 5 and 80 mA cm$^{-2}$ in order to vary the porosity of the layers. The etching time was also changed between 10 and 45 s to control the thickness of the layers. In this work two different types of nanoPS layers with very different properties were selected for their detailed analysis. These were named ‘nanoPS-LP’, i.e. low porosity nanoPS layers which were fabricated by applying a current density of 5 mA cm$^{-2}$ for 45 s and ‘nanoPS-HP’, or high porosity nanoPS layers, which were synthesized under constant applied current of 80 mA cm$^{-2}$ for 10 s.

Functionalization process

After the electrochemical etching process the surface of nanoPS is Si-H$_x$ terminated [20]. Accordingly, aiming at stabilizing its relatively high chemical activity, the nanoPS layers were immersed in H$_2$O$_2$ (30% v/v) for 90 min and subsequently rinsed in absolute ethanol. Surface functionalization was performed by the immersion of the nanoPS in amino-propyltriethoxysilane (APTS):toluene (2:1000) solutions for 15 min. In this process, the presence of SiO$_2$ on the surface of nanoPS (formed by the oxidation as a result of stabilization process), reacts with the APTS-based solution leading to a large surface density of amino groups [21]. It is worth mentioning that amino groups were selected for this study given that they are present in proteins and their chemical interaction with other functional groups is fairly well understood.

Fabrication of tailored surface patterns by UV interference

Tailored surface patterns based on nanoPS were fabricated by an interferential process where single pulses of an excimer laser ($\lambda = 193$ nm and $\tau = 20 \, \text{ns}$) were used to expose a fringe phase mask optimized for high efficiency in the ±1 diffraction orders. These orders are made to overlap and interfere at the surface of nanoPS layers by means of two lenses in telescope configuration. Thus, the nanoPS surface is exposed to a modulated intensity formed by the maxima and minima of interference. By using different configuration for the lenses, the period of the pattern can easily be modified. In addition, by combining different laser pulses or diverse phase masks, 2D patterns can be obtained. Further details can be found elsewhere [22].

Characterization

Optical characterization was carried out with an UV − vis spectrophotometer (Jasco V-560) equipped with a Hamamatsu R928 photomultiplier. All reflectance measurements were performed in the 400 to 800 nm range with a 2 nm interval and with 1 s integration time.

Morphological characterization of nanoPS layers and surface patterns was carried out by using a field emission scanning electron microscopy (FESEM) XL 30S-FEG (Philips) in planar (PV) and cross-sectional (CS) views. No metallization was required to characterize the samples. The effectiveness of the functionalization process of the nanoPS surfaces with APTS was evaluated using fluorescein isothiocyanate (FITC, Sigma). FITC is a fluorescent molecular probe which reacts covalently with the amino group of APTS and was visualized in a fluorescence inverted microscope (Olympus IX81, Olympus Corporation, Shinjuku, Tokyo, Japan) coupled to a CCD color camera.

Result and discussion

The porosity, $P$, of the two different types of nanoPS layers studied in this work (see experimental section) was determined by gravimetry using the following relationship [2]:

$$P(\%) = \frac{m_1 - m_2}{m_1 - m_3} \cdot 100$$  

$\rho_1$ being the silicon mass before the electrochemical etching process, $m_2$ the mass after the nanoPS layer is formed, and $m_3$ the mass remaining upon removal of the nanoPS layer in alkaline solutions. The average porosity (mean and standard deviation of 10 measurements per each type of layer) was found to be 42 ± 8% and 72 ± 5%. From now on, these samples will be referred to as low porosity (nanoPS-LP) and high porosity (nanoPS-HP) respectively.

Figure 1 shows PV and CS FESEM images of two representative nanoPS-LP (figures 1(a) and (c)) and nanoPS-HP (figures 1(b) and (d)) layers before laser processing. It was
determined by image analysis that the nanoPS-LP layers have an average pore size of 20 nm in diameter and a surface pore density of 38 ± 1%, whereas nanoPS-HP layers show an average pore diameter of 50 nm and a surface pore density of 68 ± 1%. These parameters are in good agreement with the porosities determined by gravimetry. In fact, in both cases the surface porosity is smaller than bulk porosity, an effect already reported for nanoPS. Additionally, CS FESEM images show that the nanoPS layers have a thickness around 500 nm in both cases. Besides, the pore structure can be described as an interlaced pore network in the case of nanoPS-LP and as an array of longitudinal pores in the case of nanoPS-HP.

Figure 2(a) shows the experimental reflectance spectra of the two different layers (nanoPS-LP and nanoPS-HP) of similar thickness (~500 nm) and that of crystalline silicon as a reference. Typical thin film interferences are observed in the reflectance spectra of both porous layers. As expected, increased light reflection towards the blue part of the spectra (shorter wavelengths) is manifested in nanoPS-LP. As we will discuss below, this behavior has a significant effect in the morphology of the layers upon laser irradiation. From these spectra, the refractive index in the visible range of both layers is represented in figure 2(b).

Figure 3 shows 1D patterns fabricated on nanoPS-LP (figure 3(a)) and nanoPS-HP layers (figure 3(b)) by the incidence of one laser pulse, setting the laser fluence to 43 mJ cm\(^{-2}\) and a combination of projection lenses to obtain periods of 3(\(\mu\)m and 31\(\mu\)m respectively). The period of the pattern can be changed just by adjusting the laser intensity profile, i.e. shallow transformed regions with reduced pore density and increased pore diameter for nanoPS-LP and alternate modulated regions with in-depth reduction of the thickness and formation of Si NPs for nanoPS-HP, can be associated to three main factors. First, the higher reflectance of the nanoPS-LP layers in the UV range which reduces the power density of the layer that is absorbed. Second, the thermal conductivity from nanoPS layer which is reduced for higher porosities [25]. In this case, the lower thermal conductivity of nanoPS-HP favors the increase of temperature in the irradiate regions, reaching the melting temperature faster and allowing the melt depth going further in-depth. Third, the smaller density of the nanoPS-HP layer gives advantage to the formation of bigger and well isolated Si NPs, whereas the higher density of the nanoPS-LP promote the coalescence of neighbor molten NPs and herein the percolation threshold is reached easily and the formation of big NPs is truncated. As discussed below, the production of biofunctionalized patterns on nanoPS relies on the formation of regions with very different physico-chemical and morphological properties, which was not accomplished using nanoPS-LP samples. In contrast, alternate modulated regions with in-depth reduction of the thickness and formation of Si NPs were produced on nanoPS-HP. Accordingly, nanoPS-LP layers were not used for the biofunctionalization processes.

In order to prove the versatility of the laser technique to produce different patterns on nanoPS surfaces, figure 5 shows PV SEM images of several other patterns fabricated on nanoPS-LP layers. Figures 5(a) and (b) show 1D patterns but with different periods, 1.7 \(\mu\)m and 31 \(\mu\)m respectively. The period of the pattern can be changed just by adjusting the configuration lenses which produce the laser interference.

In addition, figures 5(c) and (d) show two different 2D patterns. Figure 5(c) shows pattern consisting in a square lattice grid of irradiated zones and almost untransformed zones. This pattern was fabricated by two pulses of laser, rotating 90° the sample between pulses. Figure 5(d) shows a 2D oblique lattice. To fabricate this pattern, a pair of phase masks with 90° relative orientation is required to modulate the laser beam so as to obtain a 2D irradiation pattern. As it was the case of the 1D patterns, the period of the two different 2D patterns can be controlled by adjusting the configuration of the projection lenses.

As a proof of concept, the various laser fabricated patterns have been tested as selective biofunctionalization platforms. The biocompatibility of nanoPS has been extensively studied due to its many potential applications in the broad field of...
Figure 1. FESEM planar view (PV) images of the surface of (a) nanoPS-LP and (b) nanoPS-HP as formed. (c) Cross sectional (CS) images of characteristic nanoPS-LP and (d) nanoPS-HP layers. NanoPS-LP was formed using an applied current density of 5 mA cm$^{-2}$ for 45 s and nanoPS-HP was formed under an applied current density of 80 mA cm$^{-2}$ for 10 s.

Figure 2. (a) Experimental reflectance spectra of silicon reference (black line), nanoPS-LP layer (blue line) and nanoPS-HP layer (red line). (b) Refractive index of nanoPS layer calculated from reflectance spectra [23].

biomedicine (see for example [26]). Figure 6(a) shows a fluorescence microscope image of nanoPS biofunctionalized with APTS. The surface of nanoPS is biofunctionalized by immersion into a APTS:toluene (2:1000) solutions after a previous stabilization process (immersion in H$_2$O$_2$ solutions for 90 min, as described above). In order to be able to assess the efficiency of the biofunctionalization process by fluorescence microscopy, FITC, which is known to specifically react with amino groups, was used. As shown in figure 6(a), the biofunctionalization process results in an uniform fluorescence intensity across the image proving that homogenous biofunctionalized layers are produced on top of the surface of nanoPS. Following this process, amino groups are bonded on the surface of nanoPS by a previous oxidation of the surface, remaining intact most of the O-Si-CH$_2$-CH$_2$-CH$_2$-NH$_2$ groups present in APTS molecules [27, 28].
Figure 3. FESEM planar view images of 1D patterns formed with a laser fluence of 43 mJ cm\(^{-2}\) and a period of 6.3 μm on (a) nanoPS-LP and (b) nanoPS-HP layers. Magnified views of the transformed zones for (c) nanoPS-LP and (d) nanoPS-HP layers.

Figure 4. Slightly tilted cross section FESEM images of the patterns formed on (a) nanoPS-LP layer and (b) nanoPS-HP layer. Magnified views of the transformed zones are shown in (c) for nanoPS-LP and (d) nanoPS-HP layer.
To create selective biofunctionalized platforms, direct laser writing has been previously used \[29\]. Since laser irradiation alters the properties of the biofunctionalized layers, selective biofunctionalized platforms can only be obtained from homogeneous surfaces by means of an ‘on and off’ irradiation process, i.e. alternating irradiated and not irradiated regions. However, by phase mask laser interference, the same platforms can be fabricated with a single shot in a time efficient process (ns range) and over relatively large areas (mm\(^2\)). Figure 6(b) shows a fluorescence image of the platform fabricated after exposure to one laser pulse with a fluence 45 mJ cm\(^{-2}\) and a period of 6.3 μm to the homogeneous APTS-biofunctionalized nanoPS-HP layer shown in figure 6(a). The resulting platform is based on regions where the laser irradiation has altered the biofunctionalization layer (dark fringes), and untransformed biofunctionalized fringes (lighter areas). As a consequence, chemical interaction with other functional groups would preferentially occur at the biofunctionalized fringes.

Although figure 6(b) indicates that in the regions exposed to the laser intensity minima the biofunctionalized layer remains almost untransformed, it would be desirable that the process of patterning the biofunctionalized platforms were carried out in such a way that the biofunctionalization layer were not irradiated by the laser beam. For this purpose, we have first fabricated by phase mask UV laser interference 1D patterns on fresh nanoPS-HP layers and, eventually, these patterns were subjected to the biofunctionalization process. Figures 7(a) and (b) show two different selective biofunctionalized platforms
Figure 7. 1D selective biofunctionalized platforms with a period of 6.3 μm based on 1D nanoPS pattern fabricated by laser interference with different laser fluence; (a) 45 mJ cm\(^{-2}\) and (b) 22 mJ cm\(^{-2}\).

Figure 8. Percentage of non-biofunctionalized region normalized to the period, for samples that have been biofunctionalized before (●) and after (○) laser irradiation. The continuous line represents the percentage of melted region calculated using the heat flow equation (see [24] for details).

As shown in figures 7, the platforms are also formed by efficient biofunctionalization fringes (lighter areas) and regions in which the biofunctionalization process did not produce an efficient homogeneous biofunctionalized layer (darker areas). In this occasion, the different biocompatibility between untransformed nanoPS surface and Si NPs obtained after laser irradiation allows the development of these of platforms. The higher surface chemical reactivity of the nanoPS regions in comparison to the ones with SiNPs makes easy the bonding of O-Si-CH\(_2\)-CH\(_2\)-CH\(_2\)-NH\(_2\) groups present in APTS molecules. In addition, the higher surface area of the nanoPS layers along with their porous structure allow to obtain homogeneous biofunctionalized layers by the process described below.

Finally, a series of fringes with fluencies in the 12–60 mJ cm\(^{-2}\) range where produced by the two process described above, i.e. after and before the biofunctionalization process. Fluorescence images show that by changing the laser fluence, the width of the biofunctionalized fringes can be selectively tailored. Average profiles of the fluorescence signal along the period have been obtained at different fluences and the regions with maximal intensity, related with the biofunctionalized fringes have been obtained. Figure 8 shows the estimated relative non-biofunctionalized width along the period for the different fringes analyzed, where the scale bars are related with the quality of the fluorescence images. Fringes biofunctionalized after and before laser irradiation have a similar behavior; biofunctionalized regions decrease in the 50 to 25% range as the fluence increase from 12 to 60 mJ cm\(^{-2}\) and tend to saturate for high fluences. In addition, the calculation of the percentage of melted regions in the total irradiated area obtained as described in [24] has been included in figure 8. Simulation of melted and non-biofunctionalized regions are in good agreement, within the experimental error. This suggests that the morphology of the surface of nanoPS-HP is a key parameter since it determines the fluorescence intensity and thus the adhesion and activity of the biofunctionalized regions. Accordingly, it can be affirmed that these selective biofunctionalized platforms are promising candidates for novel biological and biomedical applications.

Conclusions

Phase mask UV laser interference has been demonstrated as a versatile and promising technique for the fabrication of 1D- and 2D patterns on nanoPS in an efficient time process (ns range) and over relatively large areas (mm\(^2\)). The patterns generated upon laser interference are composed by nanoPS areas and regions where nanoPS layer has melted and transformed into Si NPs for high porosity layers. By controlling the main parameters in the fabrication process such as porosity of nanoPS layer, laser fluence or projection lenses configuration, the principal characteristic of the patterns can be determined including the width of transformed regions, period of the patterns and even the diameter of the Si NPs.

Due to the high reactivity of nanoPS which is unaltered in the regions irradiated with lower intensity and allows
nanoPS become in a biocompatible material, selective biofunctionalization platforms can be obtained from these patterns. Percentage of biofunctionalized region, motive and size of periodic patterns can be tailored by the laser parameters. In this way, these platforms are ideal candidates for the development of novel biological and biomedical applications.

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